

(REV. 05/03)	U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE  INFORMATION DISCLOSURE CITATION <i>(Use several sheets if necessary)</i>	ATTY. DOCKET NO.	APPLICATION NO.
		BDL-487XX	10/549444
		APPLICANT: Eric Sion et al.	
		FILING DATE Herewith	TC ART UNIT

## U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	PUBLICATION/ ISSUE DATE	NAME	CLASS	SUBCLASS	FILING DATE
	US 6,001,419	12/14/1999	Leluan et al. [Delperier]			
	US					
	US					
	US					
	US					

## FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES      NO
	WO 96/15285	5/23/1996	WIPO			X

## OTHER DOCUMENTS (including Author, Title, Date, Pertinent Pages, etc.)

	Glasier, G.F. et al: "Formation of pyrolytic carbon during the pyrolysis of ethane at high conversions," CARBON, Elsevier Science Publishing, New York, NY, vol. 39, no.1, pages 15-23 (January 2001).
	Becker, A., et al: "Chemistry and kinetics of chemical vapor deposition of pyrocarbon—II pyrocarbon deposition from ethylene, acetylene and 1,3-butadiene in the low temperature regime," CARBON, Elsevier Science Publishing, New York, NY, vol. 36, no. 3, pages 177-199 (1998).
	Delhaes, P.: "Chemical vapor deposition and infiltration processes of carbon materials," CARBON, Elsevier Science Publishing, New York, NY, vol. 40, no. 5, pages 641-657 (April 2002).

## EXAMINER

## DATE CONSIDERED

\*EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

CLG/mc/326695-1